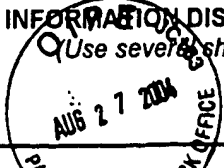


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) 	Docket Number (Optional) 16592-2	Application Number 10/774,839
	Applicant(s) Gary S. Tompa, et al.	
	Filing Date February 9, 2004	Group Art Unit 2878

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CH		2002/0174367	11/21/02	Kimmel et al.	713	201	

FOREIGN PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
CH		EP 0 542 561 A1	05/19/93	Westrom, et al.	G01T1	00		
		JP 10132944	5/22/98	Jeon-Seo Park	G01T1	17		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
CH		Brent R. Blaes and Martin G. Buehler, "SEU/SRAM as a Process Monitor", IEEE Transactions on Semiconductor Manufacturing, Vol. 7, No. 3, August, 1994, Pages 319-324	

Examiner Signature CONSTANTINE HANNAHER	Date Considered JAN 4 2006
EXAMINER: Indicate if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Form PTO-A820 (also form PTO-1449)